



Docket No.: F06-436-US

FUJIT.081

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re patent application of

Hiroyuki KANO, et al.

Serial No.: 10/569,838

Group Art Unit: Unknown

Filing Date: February 24, 2006

Examiner: Unknown

For: METHOD FOR PRODUCING CARBON NANOWALLS, CARBON
NANOWALL, AND APPARATUS FOR PRODUCING CARBON
NANOWALLS

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

SUBMISSION OF DECLARATION

Sir:

Submitted herewith is the signed declaration for the above-identified patent application.

The fees including the surcharge for the late filing of the declaration were paid on February 24,
2006.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's

Deposit Account No. 50-0481.

Respectfully submitted,

Sean M. McGinn, Esq.
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Date:

5/5/06

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